С П И С Ъ К

на цитирания на научните трудове на

чл.-кор. дфн ГЕОРГИ МИХАЙЛОВ МЛАДЕНОВ

от Институт по електроника при БАН

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高纯金属铪具有特殊的物理化学性质和核性能， 在核反应堆和航空航天等工业领域具有广泛的 应用前景. 总结了国内外高纯金属铪常用的几种制备方法， 包括熔盐电解， 碘化精炼， 电子束熔炼和电子束悬浮区熔， 概述了各方法的原理和研究进展， 并分析比较了各制备方法的优

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